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Name: Manzeng Ma

Institution: Cangzhou Normal University

<u>City:</u> Cangzhou Country: China

Phone:

Academic Email:

I declare, I confirm, I certify and I sign that I received substantial, important, line by line peer review with several and substantial comments, important remarks and hints from, at least, 3 Reviewers and the Assistant Editor for my paper: ... <u>An Infrared Image Target Segmentation Based on Improved Threshold Method</u>...with Authors: ... <u>Manzeng Ma and Ruirui Zhang</u>.......

I would like to thank all the reviewers for their thoughtful comments and efforts towards improving our manuscript. We revised the manuscript with special attention to the comments that we received from, at least, 3 reviewers that they were experts, specialist in the area of my paper.

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Date: July 26, 2021